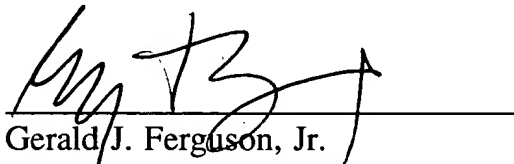


REMARKS

Applicant hereby elects the invention of Group I including claims 8-23, 27-29, and 35-36 drawn to an apparatus for processing a semiconductor wafer. Moreover, applicant elects the first species recited in claims 8-15, 21-23, and 27-29.

Examination on the merits is requested.

Respectfully submitted,



Gerald J. Ferguson, Jr.
Registration No. 23,016

Sixbey, Friedman, Leedom & Ferguson, P.C.
2010 Corporate Ridge, Suite 600
McLean, Virginia 22102
(703) 790-9110